

## **Application Data Sheet**

### **Application Information**

Filing Date:: 10/28/2003 12:00:00AM  
Application Type:: Regular  
Subject Matter:: Utility  
CD\_ROM or CD-R?: None  
Title:: INTERFERENCE SYSTEM AND SEMICONDUCTOR  
EXPOSURE APAPRATUS HAVING THE SAME  
Attorney Docket Number:: 00684.003208.1  
Total Drawing Sheets:: 2  
Small Entity?: No  
Secrecy Order in Parent Appl.?: No

### **Applicant Information**

Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Chidane  
Family Name:: OUCHI  
City of Residence:: Utsunomiya-shi  
Country of Residence:: Japan

### **Correspondence Information**

Correspondence Customer Number:: 5514

### **Representative Information**

|                                  |       |
|----------------------------------|-------|
| Representative Customer Number:: | 05514 |
|----------------------------------|-------|

**Domestic Priority Information**

| Application::    | Continuity Type:: | Parent Application:: | Parent Filing Date:: |
|------------------|-------------------|----------------------|----------------------|
| This Application | Division of       | 09/893,636           | 06/29/2001           |

**Foreign Priority Information**

| Country:: | Application Number:: | Filing Date:: | Priority Claimed:: |
|-----------|----------------------|---------------|--------------------|
| Japan     | 199435/2000 (Pat.)   | 06/30/2000    | Yes                |

**Assignee Information**

Assignee name:: CANON KABUSHIKI KAISHA  
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Country of mailing address:: Japan